Docket No.

218290US2/smc

# IN THE UNITED STATEMENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Kouichi OHTAKA, et al.

SERIAL NO:

10/050,865

GAU:

2872

COPY

FILED:

January 18, 2002

**EXAMINER:** 

FOR:

OPTICAL MODULATOR, OPTICAL MODULATOR MANUFACTURING METHOD, LIGHT INFORMATION

PROCESSING APPARATUS INCLUDING OPTICAL MODULATOR, IMAGE FORMATION APPARATUS INCLUDING

OPTICAL MODULATOR, AND IMAGE PROJECTION AND DISPLAY APPARATUS INCLUDING OPTICAL

**MODULATOR** 

# INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 CFR 1.97

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Applicant(s) wish to disclose the following information.

### REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

#### RELATED CASES

- ☐ Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application.

  A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

## CERTIFICATION

- Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

## **DEPOSIT ACCOUNT**

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 10/98) Marvin J. Spivak

Registration No.

24,913



SERIAL NO: 10/050,865

Sheet <u>1</u> of <u>1</u>

Group Art Unit: 2872

COPY

# STATEMENT OF RELEVANCY

References AM, AN, AP and AR on Form 1449:

These references are discussed in the specification.

AUG 2 4 2004 ST

**6** 

SHEET 1

SERIAL NO. ATTY DOCKET NO. Form PTO 1449 10/050,865 218290US2 (Modified) **APPLICANT** Kouichi OHTAKA, et al. LIST OF REFERENCES CITED BY APPLICANT FILING DATE GROUP 2872 January 18, 2002 **U.S. PATENT DOCUMENTS** SUB FILING DATE DOCUMENT **EXAMINER CLASS** DATE NAME IF APPROPRIATE CLASS INITIAL NUMBER AA AB AC AD ΑE AF AG AH ΑI ΑJ FOREIGN PATENT DOCUMENTS TRANSLATION DOCUMENT COUNTRY DATE NO YE\$ NUMBER Х 05/20/94 JAPAN (with English Abstract) 6-138403 Х 08/18/95 JAPAN (with English Abstract) AL 7-218845 х JAPAN (with English Abstract) 01/07/2000 2000-2842 AM Х 10/06/98 JAPAN (with corr. WO 96/41217) 10-510374 WO 96/41217 12/19/96 WIPO ΑO Х JAPAN (with corr. WO 96/41224) 08/30/99 ΑP 2941952 WIPO-12/19/96 WO 96/41224 AΩ X JAPAN (with corr. WO 96/41226) 03/06/2000 3016871 AR WO 96/41226 12/19/96 WIPO AS AT ΑIJ ΑV OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.) K. E. PETERSEN, Applied Physics Letters, vol. 31, no. 8, pages 521-523, "MICROMECHANICAL LIGHT MODULATOR ARRAY FABRICATED ON SILICON", October 15, 1977 AW O. SOLGAARD, et al., Optics Letters, vol. 17, no. 9, pages 688-690, "DEFORMABLE GRATING OPTICAL MODULATOR", May 1, 1992 AX Larry J. HORNBECK, SPIE Critical Reviews Series, vol. 1150, pages 86-102, "DEFORMABLE-MIRROR SPATIAL AY LIGHT MODULATORS", August, 1989 ΑZ

Examiner

Date Considered

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.